



PATENT
8097-1003

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Takahuki SHIMAMUNE et al.

Conf. 2298

Application No. 10/527,801

Group 2892

Filed October 11, 2005

Examiner E. Ullah

PROCESS FOR PRODUCING HIGH-PURITY SILICON
AND APPARATUS

RESPONSE

Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 9, 2008

Sir:

This replies to the Official Action mailed July 9,
2008.

Remarks begin on page 2 of this paper.